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**EXPEDITED PROCEDURE**  
Art Unit 2812

Docket No.: 29936/39764  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Cha Deok Dong

Application No.: 10/720,457

Confirmation No.: 4077

Filed: November 24, 2003

Art Unit: 2812

For: METHOD FOR FORMING DEVICE  
ISOLATION FILM IN SEMICONDUCTOR  
DEVICE

Examiner: M. M. Trinh

**AMENDMENT "C" AFTER FINAL ACTION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the official action dated October 9, 2007, finally rejecting claims 1-14, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.